

1 Design and analysis of magnetostrictive sensors for wireless 2 temperature sensing

3 Manjunath C. Rajagopal and Sanjiv Sinha (sanjiv@illinois.edu)

4 Department of Mechanical Science and Engineering

5 University of Illinois at Urbana-Champaign, Urbana, IL 61801, USA.

6 Abstract

7 Magnetostrictive transducers are commonly used as actuators, sonar transducers, and in
8 remote non-destructive evaluation. Their use in wireless thermometry is relatively unexplored.
9 Since magnetostriction-based sensors are passive, they could potentially enable long-term near-
10 field thermometry. While the temperature sensitivity of resonance frequency in magnetostrictive
11 transducers has been reported in previous studies, the origin of the temperature sensitivity has
12 however not been elucidated. Here, we identify material properties that determine temperature
13 sensitivity, and identify ways to improve sensitivity as well as the detection technique. Using a
14 combination of analytical and computational methods, we systematically identify the material
15 properties that directly influence the temperature coefficient of resonance frequency (TCF). We
16 first experimentally measure the shift in resonance frequency due to temperature changes in a
17 Metglas strip to be $0.03\%K^{-1}$. Using insights from theory, we then experimentally demonstrate a
18 5-fold improvement to the TCF by using Terfenol in place of Metglas as the magnetostrictive
19 sensor material. We further demonstrate an alternate temperature sensing technique that does not
20 require measuring the resonance frequency, consequently reducing instrument complexity. This
21 work provides a general framework to analyze magnetostrictive materials and the sensing scheme
22 for near-field wireless thermometry.

23

24 I. Introduction

25 Wireless temperature sensing has enabled applications such as environmental temperature
26 monitoring [1], [2], data center cooling monitoring [2], [3], core body temperature measurements
27 [4], etc. Such techniques typically involve RFID tags [5], [6], LC circuits [7], [8], SAW resonators

1

This article may be downloaded for personal use only. Any other use requires prior permission of the author and AIP Publishing. This article appeared in Review of Scientific Instruments, 2021 and may be found at <https://doi.org/10.1063/5.0035296>

28 [9], [10], etc., which require extensive fabrication [11], [12], high instrument complexity [5], [13],
29 and rigorous signal decoding techniques [1], [9]. Here, we explore magnetostrictive transducers as
30 a potential alternative for near-field wireless thermometry. Magnetostrictive materials respond to
31 an excitation magnetic flux by deforming mechanically, initiating an elastic wave in the material.
32 In turn, the elastic wave induces a magnetic flux, which reaches a peak when the excitation
33 magnetic flux is modulated at the natural mechanical frequency of the transducer. Thus, a coil near
34 a magnetostrictive material can provide a direct electrical readout of the sensing parameter, which
35 has enabled several low-cost [14], [15] applications such as anti-theft tags [16], food package
36 tagging [17], fluid property measurements [18], etc. For instance, magnetostrictive transducers
37 have been used for fluid property measurements such as pressure [18], [19], velocity [18], [20],
38 viscosity [21], [22], humidity [18], [23], etc., and in industrial applications such as positioning
39 actuators [24], sonar transducers [25], torque sensors [26], etc. Typical fluid properties such as
40 pressure, viscosity, etc. affect the loading and/or damping of a resonating magnetostrictive sensor,
41 which changes its resonance frequency [27]. On the other hand, temperature changes affect the
42 intrinsic material properties, especially the Young's modulus of the magnetostrictive material [27],
43 which results in a resonance frequency shift. While the temperature sensitivity of resonance
44 frequency in magnetostrictive transducers has been reported in previous studies [23], [27]–[29],
45 the origin of the temperature sensitivity has however not been elucidated.

46 There has been a growing interest in understanding the temperature dependence of the
47 Young's modulus in magnetostrictive materials [29]–[33]. Previous work [29] used a simplified
48 constitutive model to propose that the temperature-dependent anisotropy field could be the cause
49 for the temperature dependence of Young's modulus. However, the anisotropy field's temperature
50 dependence has neither been quantified nor been used to demonstrate any improvement to the
51 temperature sensitivity. Recent studies [30]–[33] have provided more detailed non-linear
52 constitutive models that utilize fundamental material properties in modeling the Young's modulus
53 as a function of temperature and bias fields. Such studies [30]–[33] report on thermo-magneto-
54 mechanical modeling of magnetostrictive materials, but lack direct experimental validation.
55 Therefore, there is a need for systematic identification of new materials and/or new detection
56 techniques that improve the sensitivity of magnetostrictive sensors to temperature changes.

57 In this work, we modify previously reported non-linear constitutive equations [30], and use
58 them to both analytically and computationally model a magnetostriction-based temperature sensor.

59 We perform a sensitivity analysis, and experimentally demonstrate a 5-fold improvement to the
60 temperature coefficient of resonance frequency (TCF). Such a wireless temperature measurement
61 can be integrated into existing magnetostriction based actuators or transducers, which are currently
62 used in applications such as high-pressure pipelines [34], drilling rigs [35], food packaging [17],
63 [36], anti-theft tags [16], etc. The paper is organized as follows. In Section II, we report the thermo-
64 magneto-mechanical constitutive equations and lumped circuit model that can model the TCF and
65 capture the influence of different material properties. In Section III, we describe our experimental
66 setup, which we use to measure the TCF of Metglas. Using the experimental results, in Section
67 IV, we perform a sensitivity analysis to identify the material properties that determine temperature
68 sensitivity. We use finite element simulations to study the influence of sensor dimensions. In
69 Section V, we demonstrate an improvement to the TCF using Terfenol. We also discuss an
70 alternative sensing technique that does not require measuring the resonance frequency to measure
71 temperature changes. Overall, our work provides ways to improve the sensitivity and explores
72 alternate measurement techniques for temperature sensing through new or repurposed existing
73 magnetostrictive sensors.

74

75 **II. Modelling**

76 We model magnetostrictive transducers to gain insights that can be used to improve the sensitivity
77 and detection technique for thermometry applications. First, we develop constitutive equations to
78 predict the resonance frequency shift with temperature. Then, we develop a lumped circuit model
79 to predict the induced voltage at a pickup coil. We describe our experimental setup in detail in
80 Section III. Briefly, the magnetostrictive sensor strip is placed inside two concentric coils – one
81 for bias and the other for sensing. The resonance frequency of a magnetostrictive sensor can be
82 approximated to that of a free-standing thin-film, and is given by [37],

$$f_{res} = \frac{1}{2L} \sqrt{\frac{E}{\rho(1-\nu)}} \quad (1)$$

83 where, L is the length of the sensor, ρ is the density, ν is the Poisson's ratio, and E is the Young's
84 modulus. The sensitivity to temperatures can be defined through the temperature coefficient of
85 resonance frequency (TCF) which is $\Delta f / (\Delta T \cdot f_0)$, where Δf is the change in resonance frequency

86 from f_0 due to a change in temperature ΔT from T_0 . In Section II a, we introduce constitutive
 87 equations that can be used to model the TCF for a magnetostrictive material. In Section II b, we
 88 develop a lumped circuit model that can provide insight into the detection technique, especially on
 89 the influence of sensor dimensions.

90

91 **II. a. Thermo-magneto-mechanical model (static analysis)**

92 In this Section, we discuss thermo-magneto-mechanical constitutive equations that can capture the
 93 experimentally observed variation in the resonance frequency of magnetostrictive sensors due to
 94 changes in bias fields and temperatures. The Young's modulus of magnetostrictive materials are
 95 typically a function of the applied magnetic field (H), the film stress (σ), temperature (T), and the
 96 magnetostrictive strain (λ). The relationship between the induced strain (ϵ), magnetization (M),
 97 and the applied magnetic field (H) has been analytically modeled in 1D in previous work [30]. We
 98 use a modified version of this analytical model, which we describe in the supplementary section.
 99 We show in the supplementary section that this analytical model can predict the experimentally
 100 measured magnetostrictive strain (λ) due to an applied magnetic field (H) for a variety of
 101 magnetostrictive materials such as Terfenol, Metglas 2605, 2801, etc. (Supplementary Figure S3).
 102 We extend this model as shown in Eqns. (2)-(3) to predict the Young's modulus of the
 103 magnetostrictive material under an applied dc magnetic field (H) and for small temperature
 104 changes ΔT from room temperature.

105

$$\frac{1}{E} = \frac{1}{E_s (1 + \gamma \Delta T)} + \left(1 - \frac{M^2}{M_s^2}\right) \frac{\lambda_s}{\sigma_s} \operatorname{sech}^2\left(\frac{2\sigma}{\sigma_s}\right) + \left(2 - \tanh\left(\frac{2\sigma}{\sigma_s}\right)\right) \frac{\lambda_s M}{M_s^2} \frac{\partial M}{\partial \sigma} \quad (2)$$

$$\frac{\partial M}{\partial \sigma} = \frac{3\chi M \lambda_s \left(1 - \beta \Delta T - \frac{1}{2} \tanh\left(\frac{2\sigma}{\sigma_s}\right)\right)}{\left(\frac{\mu_0 M_s^2}{\left(\frac{M_s^T}{3\chi H_{eff}}\right)^2 - \operatorname{cosech}^2\left(\frac{3\chi H_{eff}}{M_s^T}\right)}\right) - 6\chi \sigma \lambda_s \left(1 - \beta \Delta T - \frac{\sigma_s}{4\sigma} \ln\left(\cosh\left(\frac{2\sigma}{\sigma_s}\right)\right)\right)} \quad (3)$$

106

107 where,

- 108 M is the magnetization of the magnetostrictive material,
 109 M_S is the saturation magnetization at room temperature,
 110 M_S^T is the saturation magnetization at a temperature T ,
 111 λ_S is the saturation magnetostrictive strain at room temperature,
 112 H_{eff} is the effective applied magnetic field,
 113 χ is the magnetic susceptibility of the magnetostrictive material,
 114 σ is the compressive film stress,
 115 σ_S is the stress at which magnetostrictive strain $\lambda=\lambda_S$ [38],
 116 ΔT is the change in temperature from a room temperature of 25°C,
 117 β is the temperature coefficient of the magnetostrictive strain (λ), which is given by $\beta = -\frac{1}{\lambda} \frac{d\lambda}{dT}$,
 118 γ is the temperature coefficient of the Young's modulus at magnetic saturation (E_S),
 119 μ_0 is the vacuum permeability.

120 We implemented the static thermo-magneto-mechanical model for magnetostrictive
 121 materials through analytical and finite element simulations, separately. Analytically, we use the

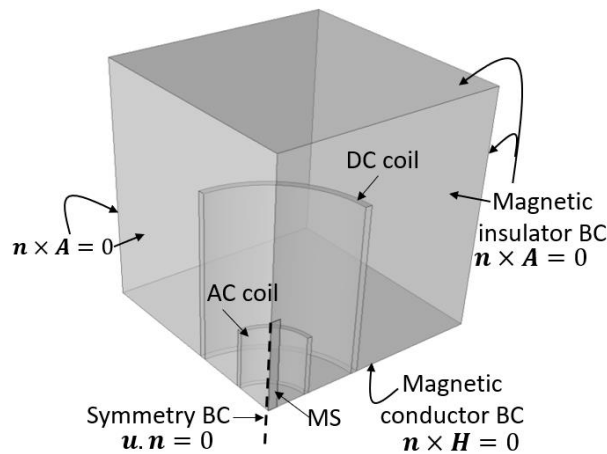


Figure 1: Computational domain of the finite element simulations. We model 1/8th of system utilizing the symmetry. MS – magnetostrictive sensor. The dimensions and relative positions of the coils and sensor correspond to our experimental setup which we discuss in Section III.

122 Supplementary Eqns. (S2)-(S4) to estimate the induced magnetization (M) using the applied
123 magnetic field (H). Since the effective applied magnetic field (H_{eff}) is also coupled to the
124 magnetization (M), we iterate the Supplementary Eqns. (S2)-(S4) to obtain the magnetization M
125 for a given applied field H . We then use Eqns. (1)-(7) to predict the Young's modulus (E) and the
126 resonance frequency (f_{res}) of the magnetostrictive sensor for different bias fields (H) and
127 temperatures.

128 For finite element modeling, we use a computational domain shown in Figure 1. We model
129 $1/8^{\text{th}}$ of the system utilizing the symmetry in the computational domain. The boundary conditions
130 are shown in Figure 1. A magnetic conductor ($\mathbf{n} \times \mathbf{H} = 0$, where \mathbf{n} is the normal vector) boundary
131 condition is applied to the bottom face of the domain, where the magnetic field is expected to be
132 normal to the face. Magnetic insulator boundary condition ($\mathbf{n} \times \mathbf{A} = 0$) is applied to the remaining
133 five faces of the domain where the magnetic field normal to the faces are expected to vanish. \mathbf{A} is
134 the magnetic vector potential. We applied symmetry boundary condition ($\mathbf{u} \cdot \mathbf{n} = 0$, where \mathbf{u} is
135 the displacement vector) at the magnetostrictive sensor's two outer surfaces, which were cut to
136 exploit the symmetry in the system. The dimensions of the coils and the sensor correspond to the
137 experimental setup we used, which we discuss in Section III. We use COMSOL Multiphysics to
138 solve Maxwell's equations and mechanical constitutive relations. We incorporated Eqns. (2)-(3)
139 and Supplementary Eqns. (S1)-(S4) in the finite element model to capture the temperature and the
140 magnetic field dependencies of the Young's modulus (E) of the magnetostrictive sensor. We then
141 used eigenfrequency analysis to extract the resonance frequency (f_{res}) of the magnetostrictive
142 sensor.

143

144 **II. b. Lumped circuit model (dynamic analysis)**

145 In the previous section, we discussed a static thermo-magneto-mechanical analysis to predict the
146 material property variation with bias fields and temperatures. In this section, we model the
147 vibrating magnetostrictive sensor using a lumped circuit model that couples the magnetic and
148 kinematic circuits. Consider a magnetostrictive rod of area A and length l wrapped with a current-
149 carrying coil (Figure 2). An ac current of I is supplied to the coil and the output voltage V is
150 measured. We consider the kinematic circuit to be a parallel RLC network. Spring constant is

151 modeled as an equivalent resistance (R), mass of the rod is modelled as an equivalent inductor
 152 (M), and compliance (C^H) is modelled as an equivalent capacitance. Compliance at a constant
 153 magnetic field is defined as $C^H = s^H l/A$, where s^H is the elastic compliance defined as $s^H = \frac{\partial \epsilon}{\partial \sigma}$
 154 at a constant field H . We perform our analysis using the mobility representation of
 155 magnetostriction [39], where $\theta:1$ acts as the turns ratio of an electromechanical transformer
 156 relating the mechanical force F to the electric current I , and the velocity v to the voltage in the

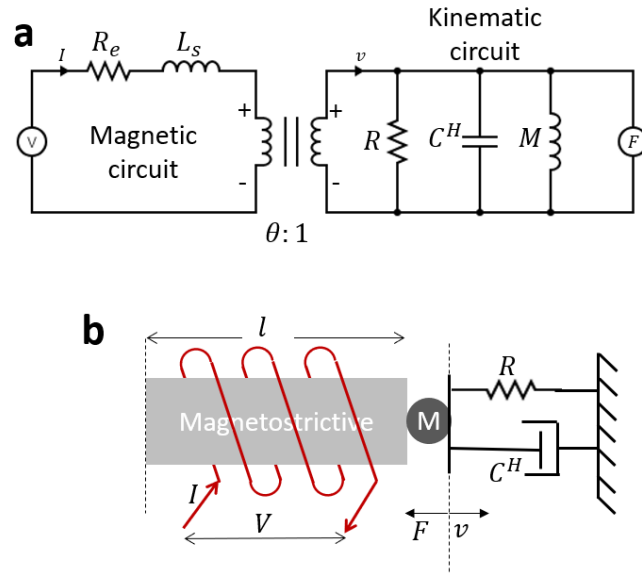


Figure 2: a) Equivalent circuit diagram of the electromechanical coupling between the ac coil and the magnetostrictive sensor. b) Schematic of the magnetostrictive material wrapped with a coil shown along with an equivalent free body diagram.

157 circuit, V .

158 The measured output voltage V in the magnetic circuit can be written as,

$$V = IR_e + j\omega L^S I + \frac{ANd}{s^H l} v \quad (4)$$

159

160 Where, R_e is the electrical resistance of the coil, L^S is the inductance of the coil, ω is the frequency
 161 of the ac current, N is the number of turns in the coil, v is the net velocity of the magnetostrictive
 162 rod's end surface, and d is the magnetostrictive constant defined as $d = \frac{\partial \epsilon}{\partial H}$ at a given stress. The
 163 net force in the magnetostrictive rod is given by,

$$F = \frac{-v}{\frac{1}{R} + j\omega C^H + \frac{1}{j\omega M}} + \frac{ANd}{s^H l} I \quad (5)$$

164

165 Since the magnetostrictive sensor is not constrained ($F = 0$), we can combine Eqns. (4) and (5),
 166 to get the measured output voltage V as,

$$V = IR_e + j\omega L^S I + \frac{\theta^2 R j\omega M I}{j\omega M + R(1 - \omega^2 C^H M)} \quad (6)$$

167

168 where, $\theta = \frac{ANd}{s^H l}$ is the electromechanical coupling factor. We can also represent the output voltage
 169 as $V = V_{ns} + V_{ind}$, where V_{ns} is the voltage across the coil when there is no magnetostrictive strip
 170 inside (corresponding to the first two terms in Eqn. (6)), and V_{ind} is the induced voltage due to the
 171 vibrating magnetostrictive strip (corresponding to the last term in Eqn. (6)).

172

173 **III. Experimental setup**

174 Figure 3 shows the schematic of the experimental setup to measure the magnetostrictive sensor
 175 response at different bath temperatures. We use Metglas 2605 TCA magnetostrictive strips (38
 176 mm x 4 mm x 30 μ m) taken from commercially available Sensormatic anti-theft tags. The Metglas
 177 strip is placed inside a sensing coil (ϕ 17 mm x 25 mm) by vertically suspending the strip using a
 178 thread attached to the center. Keithley 6221 supplies the ac current to the sensing coil at a set
 179 frequency, whereas the Lock-in amplifier measures the ac voltage across the coil at the same
 180 frequency. In this configuration, the sensing coil is used to provide the actuation ac magnetic field,
 181 and also to simultaneously measure the induced emf due to the sensor. The sensing coil is placed
 182 inside a bias coil (ϕ 40 mm x 70 mm), which provides the dc magnetic field. The coils and the
 183 sensor are placed inside a water beaker, which is attached with a flexible silicone heater to provide
 184 circumferential heating. The heater is controlled by a PID controller fitted with a thermocouple to
 185 control the temperature within the bath. Axial temperature variations across the heated water bath
 186 are typically less than 1 K at steady-state. We use a fluxgate magnetometer (TI DRV425EVM) to
 187 measure the magnetic field.

188
189
190
191
192
193
194
195
196
197
198
199
200
201

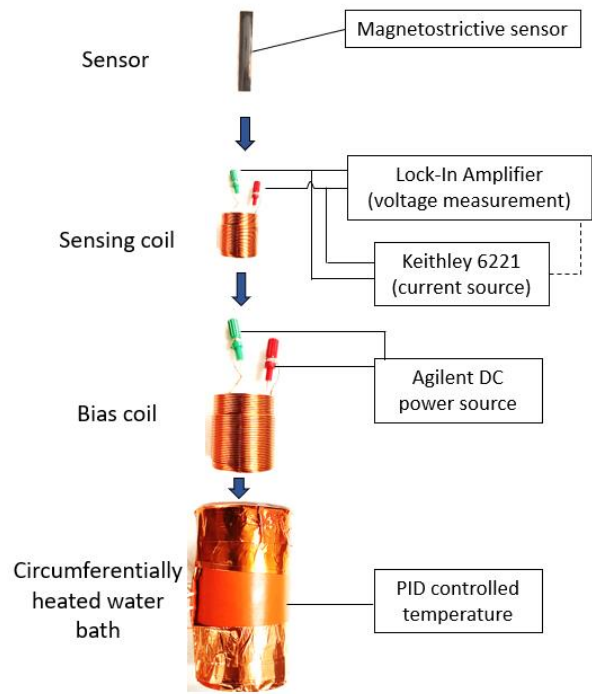


Figure 3: Schematic of the measurement setup used to measure the voltage response of magnetostrictive sensors at different bath temperatures.

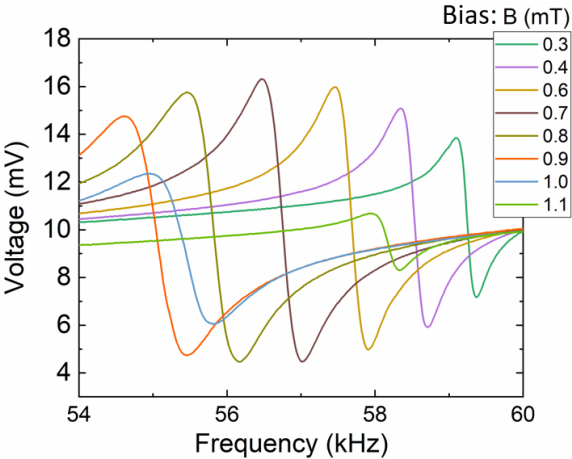


Figure 4: Voltage response of the ac coil housing the Metglas sensor in air at room temperature. The resonance frequency and the voltage amplitude at resonance are a function of the dc magnetic field (bias). An ac sensing current of 100 μ A was used for actuation.

205 Figure 4 shows a typical voltage response of the magnetostrictive sensor in air at room
 206 temperature (25°C). We discuss the characteristics of the voltage response curve in detail in
 207 Section IV. Briefly, the voltage response during a frequency sweep shows a peak, followed by a
 208 trough near the resonance frequency. The resonance frequency and the voltage amplitude at
 209 resonance are a function of the dc magnetic field (bias) as shown in Figure 4. The resonance
 210 frequency and Q factor decrease with the bias field for fields <0.18 A, but they increase at higher
 211 bias magnetic fields (Supplementary Figure S2). On the other hand, the voltage amplitude initially
 212 increases with the bias field but decreases at higher bias magnetic fields (Figure 4). When the
 213 entire setup is placed in a water bath as shown in Figure 3, the Q factor of the sensor reduces,
 214 especially at very low and very high bias field (Supplementary Figures S1, S2). We changed the
 215 temperature of the water bath to observe the resonance frequency shifts with temperature as shown
 216 in Figure 5. We denote the resonance frequency at $T_0=30^\circ\text{C}$ as f_0 . The shift in resonance frequency
 217 (Δf) due to temperature change is bias-dependent. At low bias fields, the resonance frequency
 218 decreases with temperature, whereas at high bias fields it increases with temperature. At
 219 intermediate and very high bias fields, the resonance frequency does not change significantly with
 220 temperature. We note that throughout this work, we extract the resonance frequency using the
 221 trough in the voltage response (Figure 4) for consistency, and that the analysis does not change

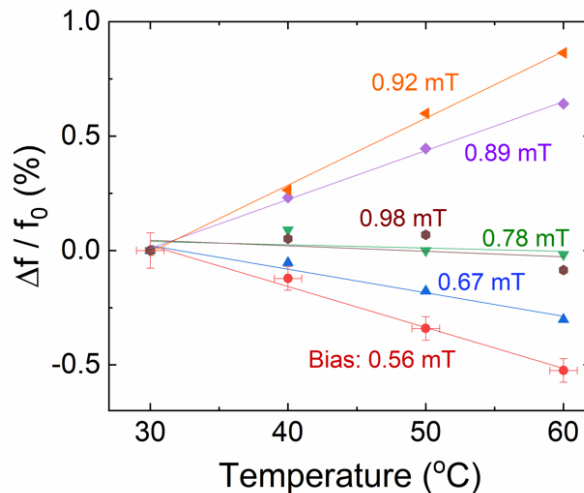


Figure 5: Shift in resonance frequency ($\Delta f/f_0$) in Metglas 2605 due to a temperature change in the water bath. f_0 corresponds to the resonance frequency at temperature $T_0=30^\circ\text{C}$. The y-error bars correspond to 1σ fitting error in estimating the resonance frequency. The x-error bars correspond to the 1σ in temperatures measured in the heated water bath during measurement.

222 significantly if the peak is used instead. From the data in Figure 5 we find that the maximum TCF
223 for the Metglas strip we used is $\sim 0.03 \text{ \%K}^{-1}$ at 30°C .

224

225 **IV. Results**

226 We use our experimental results to first validate our models in Section IV.a. We use the static
227 model to analyze the influence of different material properties on the TCF , in Section IV.b. Our
228 dynamic model is then used to analyze the influence of the dimensions of the sensor in Section
229 IV.c.

230 **IV. a. Validation**

231 Here, we validate our static and dynamic models with the experimental results. We plot the results
232 of the thermo-magneto-mechanical (static) models in Figure 6. The experimental data points are
233 shown as dots. The lines in Figure 6 are representative of the results from both the analytical
234 calculations and finite element simulations. The results from the finite element simulations do not
235 differ from that of the analytical model. We fit our model to our experimental data using

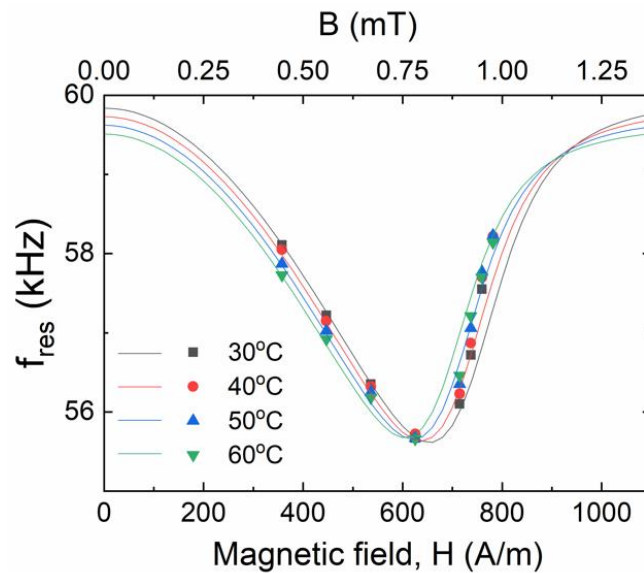


Figure 6: Resonance frequency of the Metglas 2605 strip at different temperatures and dc bias fields. The dots represent experimental data points. The solid lines are representative of the fitting from both the analytical model and finite element simulations separately. The fitting parameters are provided in the supplementary section.

236 $\gamma, \beta, \chi, \sigma, \sigma_S, E_S, M_S, \lambda_S$ as fitting parameters, where the initial values for some of the material
 237 properties ($\gamma, \beta, \chi, E_S, M_S, \lambda_S$) were taken from literature [40]–[48]. We provide the fitting
 238 parameters in the supplementary information. Small modifications within an order of magnitude
 239 to the literature values [40]–[48] resulted in a good fit to the experimental data as shown in Figure
 240 6. At low bias magnetic fields, the resonance frequency is a strong function of the temperature.
 241 However, there is a cross-over in the temperature dependence of the resonance frequency at a bias
 242 field of ~ 0.75 mT. At the cross-over point (~ 0.75 mT), the resonance frequency is essentially
 243 temperature independent, as also evident from Figure 5. Similarly, there is a second cross-over at
 244 ~ 1.1 mT, where the resonance frequency is again temperature independent. In Section IV.b., we
 245 explain the significance and the reason behind these cross-over points. Overall, the thermo-
 246 magneto-mechanical model could qualitatively capture the experimentally observed resonance
 247 frequency variation with temperatures and bias fields.

248 We implemented the lumped circuit (dynamic) model analytically and used finite element
 249 simulations. First, we fit the analytical lumped circuit model (Eqn. (6)) to our experimental data
 250 as shown in Figure 7 using the terms in Eqn. (6) as fitting parameters. From Figure 7, we find that

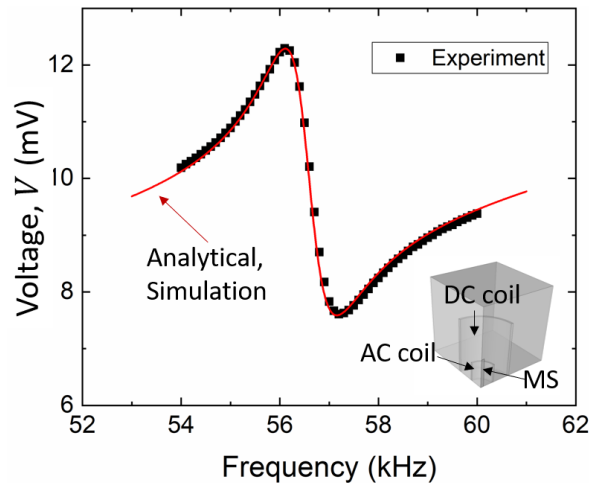


Figure 7: Voltage response of the ac coil housing the Metglas sensor in water at room temperature (25°C) at a dc bias field of 0.6 mT. Experimental data points are shown as black dots. The red solid line is representative of the results from both the analytical model and finite element simulations. The fitting parameters are provided in the supplementary section. Inset shows a schematic of the computational domain.

251 the analytical lumped circuit model could capture the voltage response of the magnetostrictive
 252 sensor during a frequency sweep. We then use the analytically estimated fit parameters R_e and L^S
 253 for the V_{ns} term in the finite element model. For the finite element model, we model the output

254 voltage as $V = V_{ns} + \Theta V_{ind}$, where $V_{ns} = IR_e + j\omega L^S I$ uses the analytically estimated fit
 255 parameters R_e and L^S ; induced voltage V_{ind} due to the magnetostrictive sensor is obtained from
 256 the Maxwell solver as $V = \oint E \cdot dl$ across the coil, and Θ is the fitting parameter. We use a
 257 frequency domain solver to estimate the induced voltage for a range of frequencies. The Young's
 258 modulus of the material was estimated for the applied dc field using the static thermo-magneto-
 259 mechanical model described in Section II. a. The red line in Figure 7 is representative of the fitting
 260 from both the analytical lumped circuit model and that of the finite element simulation. We provide
 261 details on the fitting parameters in the supplementary section. Overall, both the lumped circuit
 262 model and the finite element simulations can capture the coupling between the magnetic and
 263 kinematic circuits.

264

265 **IV. b. Material properties influencing TCF**

266 We use the validated thermo-magneto-mechanical model (Eqns. (2)-(3)) to find the material
 267 properties that influence the temperature coefficient of resonance frequency (TCF). The resonance
 268 frequency is a function of the length of the sensor (L) and the Young's modulus (E), both of which
 269 vary with the temperature. The thermal expansion coefficient (α), defined as $\alpha = \frac{1}{L} \frac{dL}{dT}$ is typically
 270 small, in the order of 10^{-6} K^{-1} , and hence does not contribute significantly to the change in the
 271 resonance frequency when $\Delta T \sim 10 \text{ K}$. The temperature dependence of the Young's modulus is
 272 therefore more dominant in causing a change in the resonance frequency. We define the
 273 temperature coefficient of Young's modulus as $TCE = \frac{1}{E} \frac{\partial E}{\partial T}$. The magnitude of the temperature
 274 coefficient of resonance frequency (TCF) is then directly proportional to TCE. As evident from
 275 Eqns. (2)-(3), E is a function of several material properties such as $\gamma, \beta, \chi, \sigma, M_S$, etc. in addition
 276 to the applied field (H) and temperature (T). To analyze the temperature dependence of E with
 277 respect to these material properties, we look at three regimes: (1) low applied magnetic field, when
 278 $M \rightarrow 0$, (2) high applied magnetic field, when $M \sim M_S/2$, and (3) at saturation magnetic fields,
 279 when $M \rightarrow M_S$.

280 At low magnetic fields, when $M \rightarrow 0$, the temperature coefficient of Young's modulus
 281 can be approximated as $TCE = \frac{1}{E} \frac{\partial E}{\partial T} = \gamma$ from Eqn. (2). Even though γ is the temperature

282 coefficient of Young's modulus at magnetic saturation (E_S), γ directly influences the temperature
 283 coefficient of Young's modulus (TCE) and hence TCF even at low magnetic fields (when $M \rightarrow$
 284 0).

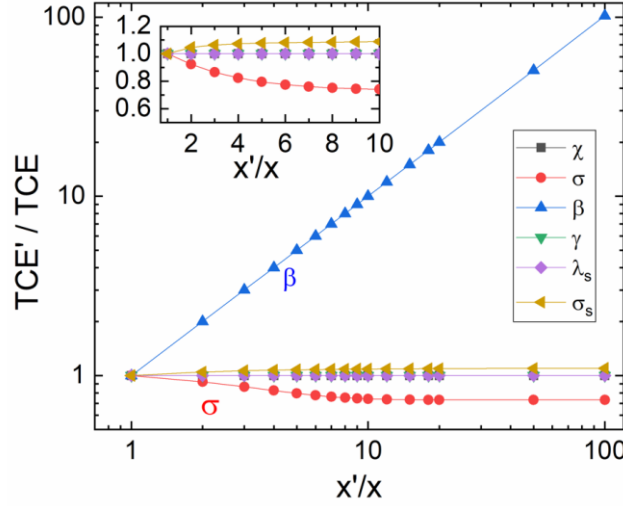


Figure 8: The change in temperature coefficient of Young's modulus (TCE) is plotted against the change in various material parameters at high magnetic fields (when $M \sim M_S/2$). x corresponds to one of the material and fitting parameters: $\chi, \sigma, \beta, \gamma, \lambda_s, \sigma_s$. Initial values for x were: $\chi=1, \gamma=10^{-4} \text{ K}^{-1}, \beta=10^{-4} \text{ K}^{-1}, \lambda_s=10^{-6}, \sigma_s=10 \text{ MPa}, \sigma=1 \text{ MPa}$. The inset shows the variation in TCE'/TCE for material parameters other than β .

285 At high magnetic fields, when $M \sim M_S/2$, the temperature coefficient of Young's modulus
 286 can be written as,

$$TCE = \left(\frac{1}{E} \frac{\partial E}{\partial T} \right)_{M \sim M_S/2} \sim - \frac{\partial \left(\frac{\partial M}{\partial \sigma} \right)}{\partial T} \frac{1}{\left(\frac{\partial M}{\partial \sigma} \right)^2} \left(\frac{\partial M}{\partial \sigma} \right)_{\Delta T=0} \quad (7)$$

287 For a change in a given material property from x (say) to x' , we plot in Figure 8, the change in the
 288 corresponding temperature coefficient of Young's modulus from TCE to TCE', when the other
 289 material properties are kept constant. Here, x represents one of the material properties:
 290 $\chi, \sigma, \beta, \gamma, \lambda_s$. We find from Figure 8 that the temperature coefficient of magnetostriction, β ,
 291 dominates the other properties in influencing the temperature coefficient of Young's modulus. The
 292 inset in Figure 8 shows that the compressive film stress σ could reduce the temperature coefficient
 293 of Young's modulus by up to $\sim 20\%$. Other material properties or fitting parameters do not
 294 influence the temperature sensitivity significantly ($< 10\%$) at high magnetic fields. Therefore, at

295 high magnetic fields (when $M \sim M_S/2$), the temperature coefficient of magnetostriction strain, β ,
296 directly influences the temperature coefficient of resonance frequency (TCF), whereas the film
297 stress, σ , negatively influences the TCF.

298 At saturation magnetic fields (when $M \rightarrow M_S$), the temperature coefficient of Young's
299 modulus is given by $TCE = \frac{1}{E} \frac{\partial E}{\partial T} = \gamma$ from Eqn. (2), which is similar to regime 1 (when $M \rightarrow 0$)
300 for low applied magnetic fields. We discussed three different regimes, and they can be observed
301 in Figure 6 from the two cross-over points because γ and β have opposite signs in Metglas (see
302 Supplementary Information). The temperature coefficient of resonance frequency (TCF) for bias
303 fields from 0 mT to ~ 0.75 mT is governed by γ ; TCF for bias fields from ~ 0.75 mT to ~ 1.1 mT
304 is governed primarily by β ; and TCF for bias fields $\gg 1.1$ mT is governed by γ . We discuss in
305 Section V how we can use these material properties to identify magnetostrictive materials that
306 could have higher TCF.

307

308 **IV. c. Length-scale dependence of induced voltage**

309 In this Section, we study the influence of the dimensions of the magnetostrictive sensor on the
310 induced voltage in the coil. This could be useful in determining the minimum size of the sensor
311 that can be used, and the number of sensors required. We use the validated finite element model
312 that captured electromechanical coupling (in Figure 7). Using the same configuration of coils that
313 we used in our experimental setup and the finite element simulations, we change the dimensions
314 of the magnetostrictive sensor and observe the change in the peak induced voltage (denoted by
315 V_{ind}^P) using simulations. We used the same Rayleigh damping coefficients for all the simulations.
316 In Figure 9, we plot the ratio of V_{ind}^P over V_{ns} , which is representative of the signal-to-background
317 ratio, for different lengths l and widths w_r of the sensor. The no-strip voltage, V_{ns} , is the baseline
318 voltage that is present even without a magnetostrictive sensor. From Figure 9, we find that the
319 signal-to-background ratio (V_{ind}^P/V_{ns}) reaches zero when the length of the magnetostrictive sensor
320 is ~ 10 mm. Similarly, the signal (V_{ind}^P) drops roughly by half when the width w_r of the sensor is
321 reduced by half. Therefore, for the current configuration of measurement (Figure 3, Figure 1), we
322 expect the signal-to-background ratio to vary linearly with the length and width of the sensor,

323 especially when l :10-40 mm, w_r :2-4 mm.

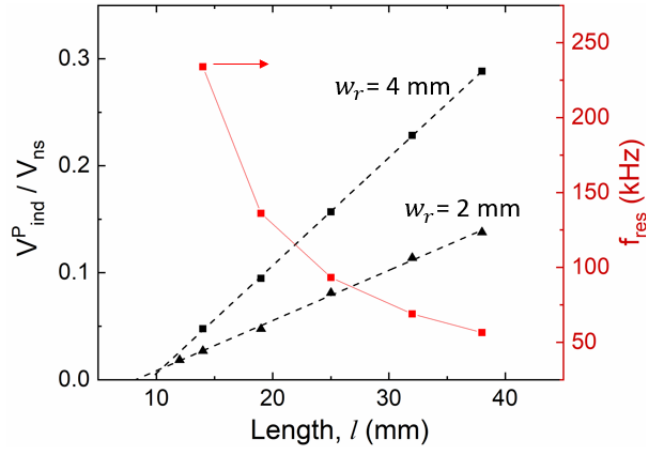


Figure 9: Signal-to-background ratio at the ac coil for different Metglas sensor dimensions are plotted along the left y-axis. The data points shown in dots are from simulations. The dashed lines are straight line fits to the simulated data. The solid red line connects the corresponding data points. The coil dimensions correspond to that of the experimental setup described in Section III.

324

325 The signal-to-background ratio (V_{ind}^P/V_{ns}) drops to zero (in Figure 9) primarily because the
 326 background (V_{ns}) increases at high frequencies. The background signal is given by $V_{ns} = IR_e +$
 327 $j\omega L^S I$, where, $j\omega L^S$, the self-inductance component, is directly proportional to the frequency of
 328 operation, ω . When the sensor length l is reduced, the resonance frequency increases as shown in
 329 Figure 9, which in turn increases the background signal (V_{ns}), obscuring the signal-to-background
 330 ratio. The background signal (V_{ns}) increases 4-fold from 9.5 mV to 38 mV (Figure 10), when the
 331 sensor length is decreased from 38 mm to 14 mm. On the other hand, the peak induced voltage
 332 (V_{ind}^P) decreases ~ 2 -fold from 2.8 mV to 1.8 mV. Therefore, when using a small sensor, the
 333 reduction in the signal-to-background (V_{ind}^P/V_{ns}) ratio is primarily due to the self-inductance of
 334 the ac coil at high frequencies.

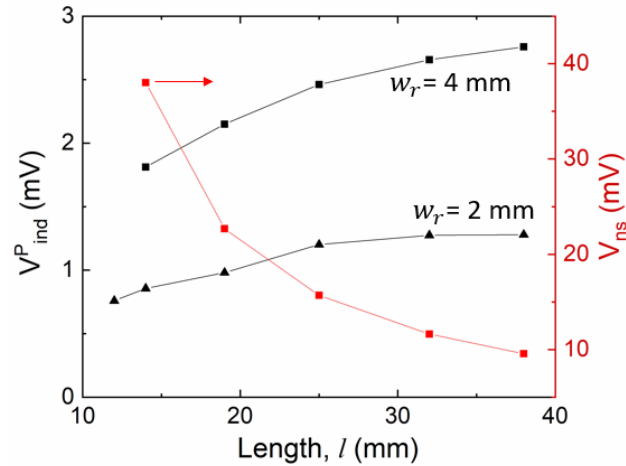


Figure 10: The peak induced voltage (V_{ind}^P) at the ac coil is plotted for different Metglas sensor dimensions on the left y-axis. The voltage at the ac coil with no magnetostrictive strip (V_{ns}) is shown on the right y-axis. The data points shown in dots are from simulations. The solid lines connect the shown data points. The coil dimensions correspond to that of the experimental setup, which is discussed in Section III.

336

337 V. Discussion

338 In this work, we first experimentally measured the shift in the resonance frequency of a
 339 magnetostrictive sensor due to temperature changes. We then analytically and computationally
 340 analyzed the material properties responsible for the shift in resonance frequency due to temperature
 341 changes. We also analyzed the influence of the sensor size on the overall measurement. In this
 342 section, we extend our analysis and provide ways to improve the sensitivity to temperature
 343 changes. We also discuss potential applications and limitations.

344 In Section IV.b., our sensitivity analysis revealed that the temperature coefficient of
 345 resonance frequency (TCF) is directly dependent on (1) γ – temperature coefficient of E_S , at low
 346 ($M \rightarrow 0$) and saturation ($M \rightarrow M_S$) bias magnetic fields, and (2) β – temperature coefficient of
 347 magnetostriction strain (λ), at high bias magnetic fields (when $M \sim M_S/2$). From the analytical
 348 fitting in Figure 6, we determined γ for the Metglas sensor to be $3.6 \times 10^{-4} \text{ K}^{-1}$. Among other
 349 magnetostrictive materials, Terfenol was previously reported [32] to have a higher $\gamma \sim 4.2 \times 10^{-3}$
 350 K^{-1} . We repeated our experiments using Terfenol (Figure 11) and found the temperature coefficient

351 of resonance frequency (TCF) to be $\sim 0.14\% \text{ K}^{-1}$, which is almost 5-fold higher than that of the
 352 Metglas sensor ($\sim 0.03\% \text{ K}^{-1}$) for a $\Delta T \sim 10 \text{ K}$. Even though the coefficient of magnetostriction (β)
 353 for Terfenol is comparable to that of Metglas, a higher γ potentially resulted in a higher TCF for
 354 Terfenol. Further, our thermo-magneto-mechanical model could capture the resonance frequency
 355 shifts in Terfenol as shown in Supplementary Figure S4. We note that a previous work [29] on
 356 $\text{Fe}_{40}\text{Ni}_{40}\text{B}_{20}$ alloy reported a $\text{TCF} \sim 0.15\% \text{ K}^{-1}$, which is comparable to the TCF we report for
 357 Terfenol. The TCF from $\text{Fe}_{40}\text{Ni}_{40}\text{B}_{20}$ is higher than the Metglas sensor we report, possibly because
 358 of a higher β , which is also evident from a wider spread in their resonance frequencies at higher
 359 magnetic fields [29]. Even though Terfenol has a higher TCF ($\sim 0.14\% \text{ K}^{-1}$), the susceptibility
 360 $\chi \sim 80$ is much lower than that of Metglas ($\chi \sim 50,000$). Thus, Terfenol requires higher bias
 361 magnetic fields ($\sim 5\text{-}10 \text{ mT}$) than that required for Metglas ($\sim 0.2\text{-}0.6 \text{ mT}$). Future work can focus
 362 on identifying materials with a high susceptibility (χ) that also have high γ and/or β to have a
 363 higher temperature coefficient of resonance frequency (TCF) at low bias fields ($< 1 \text{ mT}$).

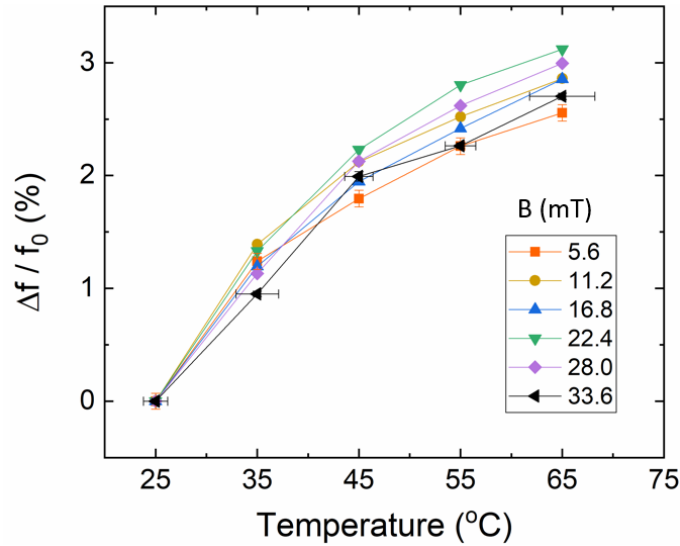


Figure 11: Shift in the resonance frequency ($\Delta f/f_0$) in a Terfenol transducer ($53 \text{ mm} \times 17 \text{ mm} \times 1.2 \text{ mm}$) due to a temperature change in the water bath. f_0 corresponds to the resonance frequency at temperature $T_0=25^\circ\text{C}$.

364 Throughout this work, we focused on the shift in resonance frequency as a potential
 365 sensing parameter to measure temperatures. However, an alternative temperature sensing
 366 technique can be developed by measuring the voltage across the ac coil at a fixed frequency near
 367 the resonance frequency of the magnetostrictive sensor. We explain it using a Metglas sensor in
 368 the same experimental setup (Figure 3). In Figure 12a, we plot the ratio $\Delta V/V_0$, where V_0 is the
 369 voltage measured at 30°C and ΔV corresponds to the difference in the measured ac voltage
 370 amplitude between 60°C and 30°C bath temperatures. The magnitude of $\Delta V/V_0$ reaches a
 371 maximum at 55.7 kHz, at a bias field of 0.89 mT. At this frequency (55.7 kHz) and bias field (0.89
 372 mT), we plot the $\Delta V/V_0$ in the inset (Figure 12b). We find that the $\Delta V/V_0$ directly increases with
 373 temperature. If we define a temperature coefficient of the measured ac voltage as $TCV = \frac{\Delta V}{V_0} \frac{1}{\Delta T}$,
 374 the TCV is roughly 0.8% K⁻¹. The TCV can be maximized by choosing a frequency and a bias
 375 field where the magnitude of $\Delta V/V_0$ is the highest across the temperature range desired (Figure
 376 12). Measuring the TCF can be time consuming and require sophisticated equipment such as
 377 network analyzers, whereas TCV can be easily measured using digital multimeters or lock-in
 378 amplifiers. The TCV can be used for temperature sensing only when the frequency shift (Δf) due
 379 to a temperature change (ΔT) is less than the width of the resonance curve. In other words, the Q -

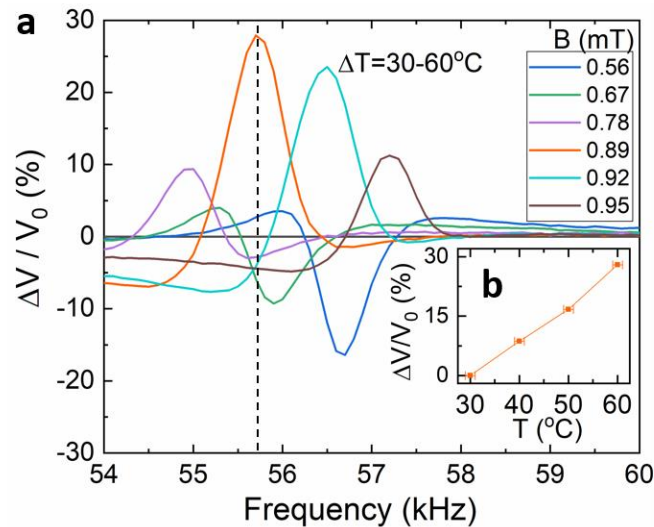


Figure 12: a) Shift in the voltage ($\Delta V/V_0$) at the ac coil due to a change in the temperature of the water bath plotted for different bias fields over a range of frequencies. ΔV corresponds to the change in the measured voltage due to a temperature change from 30°C to 60°C. V_0 is the measured voltage at 30°C. A Metglas sensor was used in setup similar to Figure 3. b) Inset plots the voltage shifts for different temperatures at a frequency of 55.7 kHz and a bias field of 0.89 mT.

380 factor of the sensor must be smaller than $(TCF \cdot \Delta T)^{-1}$. For the Metglas sensor, the Q -factor in
381 water is ~ 30 , whereas $(TCF \cdot \Delta T)^{-1}$ is ~ 110 for a $\Delta T = 30^\circ\text{C}$, thus allowing us to use TCV for
382 temperature sensing. Further, the TCV could be a function of the position and orientation of the
383 sensor with respect to the ac sensing/transmit coil. Therefore, the temperature coefficient of the
384 voltage (TCV) of the ac coil can be used for temperature sensing, especially in places where the
385 relative position and orientation of the magnetostrictive sensor remains constant with respect to
386 the coil.

387 In this work, we used a concentric coil configuration to serve as proof-of-concept
388 experiments. Helmholtz coils and/or permanent magnets can also be used instead. For instance,
389 the bias coil can be replaced by a ferromagnet magnetized to provide the appropriate bias field.
390 The magnetostrictive sensor strip can be packaged along with the ferromagnet in a manner similar
391 to the commercially available anti-theft tags [16]. Further, the commercially available anti-theft
392 tags can also be repurposed to measure temperatures either using the TCF- or TCV-based method.
393 We discussed in Section IV.c. that the signal-to-background ratio (V_{ind}^P/V_{ns}) drops when the sensor
394 dimensions are reduced. This can be overcome by two possible methods. First, two separate
395 transmit and receive coils can be placed perpendicular to each other to decouple them and remove
396 any self-inductance effects [48]. Second, multiple thin-film magnetostrictive sensors can be
397 packaged together to increase the signal-to-background ratio [49]. A magnetostrictive temperature
398 sensor package can enable *in situ* near-field applications. For instance, they can potentially enable
399 long-term near-field temperature measurements in food packaging [17], [36], culture medium
400 [50]–[52], implantable biomedical devices [4], [53], etc., and for concurrent temperature and
401 fouling measurements in industrial pipelines [34], especially in low-temperature heat exchangers
402 [54]–[56] to ensure profitable heat recovery. Overall, new or existing magnetostrictive sensor
403 packages can be suitably adapted to measure temperatures remotely, using either the TCF- or TCV-
404 based technique.

405

406 VI. Conclusion

407 In summary, we modeled and analyzed magnetostrictive materials for use in potential wireless
408 temperature sensing systems. We first experimentally measured the temperature coefficient of
409 resonance frequency (TCF) in a Metglas 2605 TCA strip to be $\sim 0.03\% \text{K}^{-1}$. We then implemented

410 thermo-magneto-mechanical constitutive equations using both analytical and finite element
411 methods to model the magnetostriction-based sensing system. The analytical and computational
412 models developed in this work provide a general framework for the sensitivity analysis of
413 magnetostriction-based temperature sensing, and can be suitably adapted to any configuration of
414 the sensing scheme. Through our sensitivity analysis, we identified the material properties of
415 interest and demonstrated a 5-fold improvement to the TCF by using Terfenol. We also explored
416 an alternate temperature sensing scheme that reduces instrument complexity by using the
417 temperature coefficient of ac voltage (TCV) at the coil, which could be used if the sensor and coil
418 locations are fixed relative to each other. In contrast to RFID- or SAW-based sensors,
419 magnetostrictive transducers offer a simple and passive near-field temperature sensing technique.
420 From a broader perspective, this work provides ways to use new or repurposed existing
421 magnetostrictive sensor packages to enable remote temperature measurements.

422

423 **Acknowledgment:**

424 This work was supported in part by funding from the National Science Foundation through Grant
425 No. NSF-CBET-17-06854

426

427 **Supplementary Information:**

428 See supplementary information for additional details on the thermo-magneto-mechanical model,
429 more validation cases, and fitting parameters for Figures 6,7.

430

431 **Data availability:**

432 The data that support the findings of this study are available from the corresponding author upon
433 reasonable request.

434

435

436 **References**

- 437 [1] Narijun Cho, Seong-Jun Song, Jae-Youl Lee, Sunyoung Kim, Shiho Kim, and Hoi-Jun
438 Yoo, “A 8-/spl mu/W, 0.3-mm/sup 2/ RF-powered transponder with temperature sensor for
439 wireless environmental monitoring,” in *2005 IEEE International Symposium on Circuits
440 and Systems*, May 2005, pp. 4763-4766 Vol. 5, doi: 10.1109/ISCAS.2005.1465697.
- 441 [2] “RFM3200 Wireless Flexible Temperature Sensor,” *Axzon website*.
442 <https://axzon.com/rfm3200-wireless-flexible-temperature-sensor/> (accessed Oct. 26, 2020).
- 443 [3] S. Saha and A. Majumdar, “Data centre temperature monitoring with ESP8266 based
444 Wireless Sensor Network and cloud based dashboard with real time alert system,” in *2017
445 Devices for Integrated Circuit (DevIC)*, Mar. 2017, pp. 307–310, doi:
446 10.1109/DEVIC.2017.8073958.
- 447 [4] “CorTemp Sensor,” *HQ, Inc.* [https://hqinc.net/home/cortemp/cortemp-products/cortemp-
448 sensor/](https://hqinc.net/home/cortemp/cortemp-products/cortemp-sensor/) (accessed Aug. 21, 2020).
- 449 [5] D. Girbau, Á. Ramos, A. Lazaro, S. Rima, and R. Villarino, “Passive Wireless Temperature
450 Sensor Based on Time-Coded UWB Chipless RFID Tags,” *IEEE Transactions on
451 Microwave Theory and Techniques*, vol. 60, no. 11, pp. 3623–3632, Nov. 2012, doi:
452 10.1109/TMTT.2012.2213838.
- 453 [6] K. Opasjumruskit *et al.*, “Self-powered wireless temperature sensors exploit RFID
454 technology,” *IEEE Pervasive Computing*, vol. 5, no. 1, pp. 54–61, Jan. 2006, doi:
455 10.1109/MPRV.2006.15.
- 456 [7] K. G. Ong, C. A. Grimes, C. L. Robbins, and R. S. Singh, “Design and application of a
457 wireless, passive, resonant-circuit environmental monitoring sensor,” *Sensors and
458 Actuators A: Physical*, vol. 93, no. 1, pp. 33–43, Aug. 2001, doi: 10.1016/S0924-
459 4247(01)00624-0.
- 460 [8] Y. Wang, Y. Jia, Q. Chen, and Y. Wang, “A Passive Wireless Temperature Sensor for
461 Harsh Environment Applications,” *Sensors*, vol. 8, no. 12, Art. no. 12, Dec. 2008, doi:
462 10.3390/s8127982.
- 463 [9] V. Kalinin, “Passive wireless strain and temperature sensors based on SAW devices,” in
464 *Proceedings. 2004 IEEE Radio and Wireless Conference (IEEE Cat. No.04TH8746)*, Sep.
465 2004, pp. 187–190, doi: 10.1109/RAWCON.2004.1389104.
- 466 [10] L. Reindl, G. Scholl, T. Ostertag, C. C. W. Ruppel, W.- Bulst, and F. Seifert, “SAW
467 devices as wireless passive sensors,” in *1996 IEEE Ultrasonics Symposium. Proceedings*,
468 Nov. 1996, vol. 1, pp. 363–367 vol.1, doi: 10.1109/ULTSYM.1996.583993.
- 469 [11] G. A. Borrero, J. P. Bravo, S. F. Mora, S. Velásquez, and F. E. Segura-Quijano, “Design
470 and fabrication of SAW pressure, temperature and impedance sensors using novel
471 multiphysics simulation models,” *Sensors and Actuators A: Physical*, vol. 203, pp. 204–
472 214, Dec. 2013, doi: 10.1016/j.sna.2013.08.021.
- 473 [12] M. Gallagher, “Design, Fabrication, and Interrogation of Integrated Wireless SAW
474 Temperature Sensors,” 2015.
- 475 [13] K. Mc Gee, P. Anandarajah, and D. Collins, “A Review of Chipless Remote Sensing
476 Solutions Based on RFID Technology,” *Sensors*, vol. 19, no. 22, Art. no. 22, Jan. 2019, doi:
477 10.3390/s19224829.
- 478 [14] R. R. Fletcher, “Low-cost electromagnetic tagging : design and implementation,” Thesis,
479 Massachusetts Institute of Technology, 2002.

- 480 [15] E. Langlois *et al.*, “Magnetic Smart Tags (MaST) for Arms Control and Treaty
481 Verification.,” Sandia National Lab. (SNL-NM), Albuquerque, NM (United States),
482 SAND2016-9417, Sep. 2016. doi: 10.2172/1562661.
- 483 [16] G. Herzer, “Magnetic materials for electronic article surveillance,” *Journal of Magnetism
484 and Magnetic Materials*, vol. 254–255, pp. 598–602, Jan. 2003, doi: 10.1016/S0304-
485 8853(02)00930-7.
- 486 [17] S. Li, A. Simonian, and B. A. Chin, “Sensors for Agriculture and the Food Industry,”
487 *Electrochem. Soc. Interface*, vol. 19, no. 4, p. 41, Jan. 2010, doi: 10.1149/2.F05104if.
- 488 [18] C. A. Grimes and D. Kouzoudis, “Remote query measurement of pressure, fluid-flow
489 velocity, and humidity using magnetoelastic thick-film sensors,” *Sensors and Actuators A:
490 Physical*, vol. 84, no. 3, pp. 205–212, Sep. 2000, doi: 10.1016/S0924-4247(00)00306-X.
- 491 [19] D. Kouzoudis and C. A. Grimes, “The frequency response of magnetoelastic sensors to
492 stress and atmospheric pressure,” *Smart Mater. Struct.*, vol. 9, no. 6, pp. 885–889, Nov.
493 2000, doi: 10.1088/0964-1726/9/6/320.
- 494 [20] D. Kouzoudis and C. A. Grimes, “Remote query fluid-flow velocity measurement using
495 magnetoelastic thick-film sensors (invited),” *Journal of Applied Physics*, vol. 87, no. 9, pp.
496 6301–6303, Apr. 2000, doi: 10.1063/1.372686.
- 497 [21] C. A. Grimes, D. Kouzoudis, and C. Mungle, “Simultaneous measurement of liquid density
498 and viscosity using remote query magnetoelastic sensors,” *Review of Scientific Instruments*,
499 vol. 71, no. 10, pp. 3822–3824, Sep. 2000, doi: 10.1063/1.1315352.
- 500 [22] K. T. Loisel and C. A. Grimes, “Viscosity measurements of viscous liquids using
501 magnetoelastic thick-film sensors,” *Review of Scientific Instruments*, vol. 71, no. 3, pp.
502 1441–1446, Mar. 2000, doi: 10.1063/1.1150477.
- 503 [23] M. K. Jain, S. Schmidt, K. G. Ong, C. Mungle, and C. A. Grimes, “Magnetoacoustic remote
504 query temperature and humidity sensors,” *Smart Mater. Struct.*, vol. 9, no. 4, pp. 502–510,
505 Aug. 2000, doi: 10.1088/0964-1726/9/4/314.
- 506 [24] Y. Yamamoto, T. Makino, and H. Matsui, “Micro-positioning and actuation devices using
507 giant magnetostriction materials,” in *Proceedings 2000 ICRA. Millennium Conference.
508 IEEE International Conference on Robotics and Automation. Symposia Proceedings (Cat.
509 No.00CH37065)*, Apr. 2000, vol. 4, pp. 3635–3640 vol.4, doi:
510 10.1109/ROBOT.2000.845298.
- 511 [25] M. J. Dapino, “On magnetostrictive materials and their use in adaptive structures,”
512 *Structural Engineering and Mechanics*, vol. 17, no. 3_4, pp. 303–329, 2004, doi:
513 10.12989/sem.2004.17.3_4.303.
- 514 [26] F. Claeysen, N. Lhermet, R. Le Letty, and P. Bouchilloux, “Actuators, transducers and
515 motors based on giant magnetostrictive materials,” *Journal of Alloys and Compounds*, vol.
516 258, no. 1, pp. 61–73, Aug. 1997, doi: 10.1016/S0925-8388(97)00070-4.
- 517 [27] C. A. Grimes *et al.*, “Wireless Magnetoelastic Resonance Sensors: A Critical Review,”
518 *Sensors*, vol. 2, no. 7, Art. no. 7, Jul. 2002, doi: 10.3390/s20700294.
- 519 [28] M. K. Jain and C. A. Grimes, “A wireless magnetoelastic micro-sensor array for
520 simultaneous measurement of temperature and pressure,” *IEEE Transactions on Magnetics*,
521 vol. 37, no. 4, pp. 2022–2024, Jul. 2001, doi: 10.1109/20.951041.
- 522 [29] A. García-Arribas, D. De Cos, J. Gutiérrez, and J. M. Barandiarán, “Selectable temperature
523 sensitivity of the magnetoelastic resonance,” *Sensors and Actuators A: Physical*, vol. 106,
524 no. 1, pp. 111–116, Sep. 2003, doi: 10.1016/S0924-4247(03)00146-8.

- 525 [30] X. J. Zheng and L. Sun, “A nonlinear constitutive model of magneto-thermo-mechanical
526 coupling for giant magnetostrictive materials,” *Journal of Applied Physics*, vol. 100, no. 6,
527 p. 063906, Sep. 2006, doi: 10.1063/1.2338834.
- 528 [31] K. Jin, Y. Kou, and X. Zheng, “A nonlinear magneto-thermo-elastic coupled hysteretic
529 constitutive model for magnetostrictive alloys,” *Journal of Magnetism and Magnetic
530 Materials*, vol. 324, no. 12, pp. 1954–1961, Jun. 2012, doi: 10.1016/j.jmmm.2012.01.028.
- 531 [32] Y. Liang and X. Zheng, “Experimental researches on magneto-thermo-mechanical
532 characterization of Terfenol-D,” *Acta Mechanica Solida Sinica*, vol. 20, no. 4, pp. 283–288,
533 Dec. 2007, doi: 10.1007/s10338-007-0733-x.
- 534 [33] Y. Xiao, H.-M. Zhou, and X.-L. Cui, “Nonlinear resonant magnetoelectric coupling effect
535 with thermal, stress and magnetic loadings in laminated composites,” *Composite Structures*,
536 vol. 128, pp. 35–41, Sep. 2015, doi: 10.1016/j.compstruct.2015.03.039.
- 537 [34] S. Vinogradov and J. L. Fisher, “New Magnetostrictive Transducers and Applications for
538 SHM of Pipes and Vessels,” presented at the ASME 2019 Pressure Vessels & Piping
539 Conference, Nov. 2019, doi: 10.1115/PVP2019-94078.
- 540 [35] M. Wiercigroch, V. Vaziri, and M. Kapitaniak, “RED: Revolutionary Drilling Technology
541 for Hard Rock Formations,” presented at the SPE/IADC Drilling Conference and
542 Exhibition, Mar. 2017, doi: 10.2118/184665-MS.
- 543 [36] A. L. Brody, “State of the art of active/intelligent food packaging,” *Institute of Food
544 Technologists Food Packaging Summit*, 2006.
- 545 [37] C. Liang, S. Morshed, and B. C. Prorok, “Correction for longitudinal mode vibration in thin
546 slender beams,” *Appl. Phys. Lett.*, vol. 90, no. 22, p. 221912, May 2007, doi:
547 10.1063/1.2745262.
- 548 [38] “A nonlinear constitutive model for Terfenol-D rods: Journal of Applied Physics: Vol 97,
549 No 5,” Accessed: Aug. 20, 2020. [Online]. Available:
550 <https://aip.scitation.org/doi/10.1063/1.1850618>.
- 551 [39] G. Engdahl, *Handbook of Giant Magnetostrictive Materials*. Elsevier, 2000.
- 552 [40] A. P. Thomas and M. R. J. Gibbs, “Anisotropy and magnetostriction in metallic glasses,”
553 *Journal of Magnetism and Magnetic Materials*, vol. 103, no. 1, pp. 97–110, Jan. 1992, doi:
554 10.1016/0304-8853(92)90242-G.
- 555 [41] “Materials from Metglas®, Inc.,” *Metglas, Inc.* <https://metglas.com/magnetic-materials/>
556 (accessed Aug. 21, 2020).
- 557 [42] R. Schulz, N. Alexandrov, J. Tétreault, R. Simoneau, and R. Roberge, “Development and
558 application of amorphous core-distribution transformers in Québec,” *JMEP*, vol. 4, no. 4,
559 pp. 430–434, Aug. 1995, doi: 10.1007/BF02649303.
- 560 [43] G. H. Hayes, W. A. Hines, D. P. Yang, and J. I. Budnick, “Low field magnetic anisotropy
561 in Metglas 2605 CO ribbons,” *Journal of Applied Physics*, vol. 57, no. 8, pp. 3511–3513,
562 Apr. 1985, doi: 10.1063/1.335044.
- 563 [44] J. Zhai, S. Dong, Z. Xing, J. Li, and D. Viehland, “Giant magnetoelectric effect in
564 Metglas/polyvinylidene-fluoride laminates,” *Appl. Phys. Lett.*, vol. 89, no. 8, p. 083507,
565 Aug. 2006, doi: 10.1063/1.2337996.
- 566 [45] M. H. Kim, K. S. Lee, and S. H. Lim, “Magnetostriction measurements of metallic glass
567 ribbon by fiber-optic Mach–Zehnder interferometry,” *Journal of Magnetism and Magnetic
568 Materials*, vol. 191, no. 1, pp. 107–112, Jan. 1999, doi: 10.1016/S0304-8853(98)00310-2.
- 569 [46] B. Kundys, Y. Bukhantsev, H. Szymczak, M. R. J. Gibbs, and R. Zuberek, “Temperature
570 dependence of saturation magnetostriction measured for Fe₈₁Si_{3.5}B_{13.5}C₂ amorphous

571 films by a bending method based on the Villari effect,” *J. Phys. D: Appl. Phys.*, vol. 35, no.
572 11, pp. 1095–1098, May 2002, doi: 10.1088/0022-3727/35/11/301.

573 [47] Z. Turgut, H. Kosai, T. Bixel, J. Scofield, S. L. Semiatin, and J. Horwath, “Hysteresis loss
574 analysis of soft magnetic materials under direct current bias conditions,” *Journal of Applied*
575 *Physics*, vol. 117, no. 17, p. 17A508, May 2015, doi: 10.1063/1.4919228.

576 [48] S. R. Green and Y. B. Gianchandani, “Wireless Magnetoelastic Monitoring of Biliary
577 Stents,” *Journal of Microelectromechanical Systems*, vol. 18, no. 1, pp. 64–78, Feb. 2009,
578 doi: 10.1109/JMEMS.2008.2008568.

579 [49] J. Tang, S. R. Green, and Y. B. Gianchandani, “Scalable, high-performance magnetoelastic
580 tags using frame-suspended hexagonal resonators,” *J. Micromech. Microeng.*, vol. 24, no.
581 6, p. 065006, Apr. 2014, doi: 10.1088/0960-1317/24/6/065006.

582 [50] S. Hur, R. Mittapally, S. Yadlapalli, P. Reddy, and E. Meyhofer, “Sub-nanowatt resolution
583 direct calorimetry for probing real-time metabolic activity of individual *C. elegans* worms,”
584 *Nature Communications*, vol. 11, no. 1, Art. no. 1, Jun. 2020, doi: 10.1038/s41467-020-
585 16690-y.

586 [51] M. C. Rajagopal *et al.*, “Transient heat release during induced mitochondrial proton
587 uncoupling,” *Communications Biology*, vol. 2, no. 1, Art. no. 1, Jul. 2019, doi:
588 10.1038/s42003-019-0535-y.

589 [52] S. Hong *et al.*, “Sub-nanowatt microfluidic single-cell calorimetry,” *Nature*
590 *Communications*, vol. 11, no. 1, Art. no. 1, Jun. 2020, doi: 10.1038/s41467-020-16697-5.

591 [53] R. Lin *et al.*, “Wireless battery-free body sensor networks using near-field-enabled
592 clothing,” *Nature Communications*, vol. 11, no. 1, Art. no. 1, Jan. 2020, doi:
593 10.1038/s41467-020-14311-2.

594 [54] M. C. Rajagopal *et al.*, “Materials-to-device design of hybrid metal-polymer heat exchanger
595 tubes for low temperature waste heat recovery,” *International Journal of Heat and Mass*
596 *Transfer*, vol. 143, p. 118497, Nov. 2019, doi: 10.1016/j.ijheatmasstransfer.2019.118497.

597 [55] X. Chen, Y. Su, D. Reay, and S. Riffat, “Recent research developments in polymer heat
598 exchangers – A review,” *Renewable and Sustainable Energy Reviews*, vol. 60, pp. 1367–
599 1386, Jul. 2016, doi: 10.1016/j.rser.2016.03.024.

600 [56] S. Sundar *et al.*, “Fouling modeling and prediction approach for heat exchangers using deep
601 learning,” *International Journal of Heat and Mass Transfer*, vol. 159, p. 120112, Oct. 2020,
602 doi: 10.1016/j.ijheatmasstransfer.2020.120112.

603

Supplementary information

Design and analysis of magnetostrictive sensors for wireless temperature sensing

Manjunath C. Rajagopal and Sanjiv Sinha*

Department of Mechanical Science and Engineering

University of Illinois at Urbana-Champaign, Urbana, IL 61801, USA

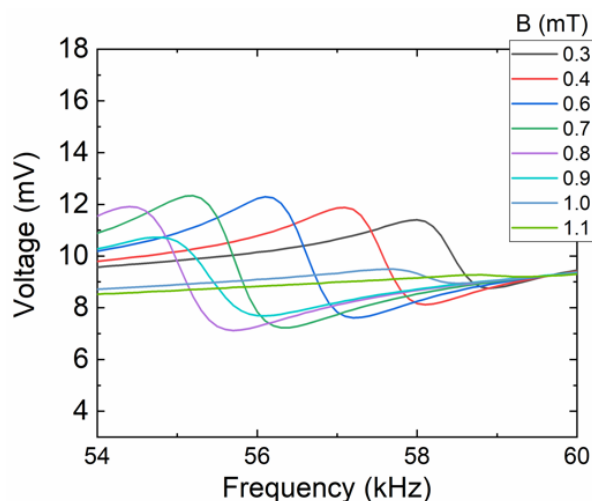


Figure S1. The voltage response of the Metglas 2605 TCA sensor in water at room temperature. The resonance frequency and the voltage amplitude at resonance are a function of the dc magnetic field (bias). An ac sensing current of 100 μ A was used for actuation.

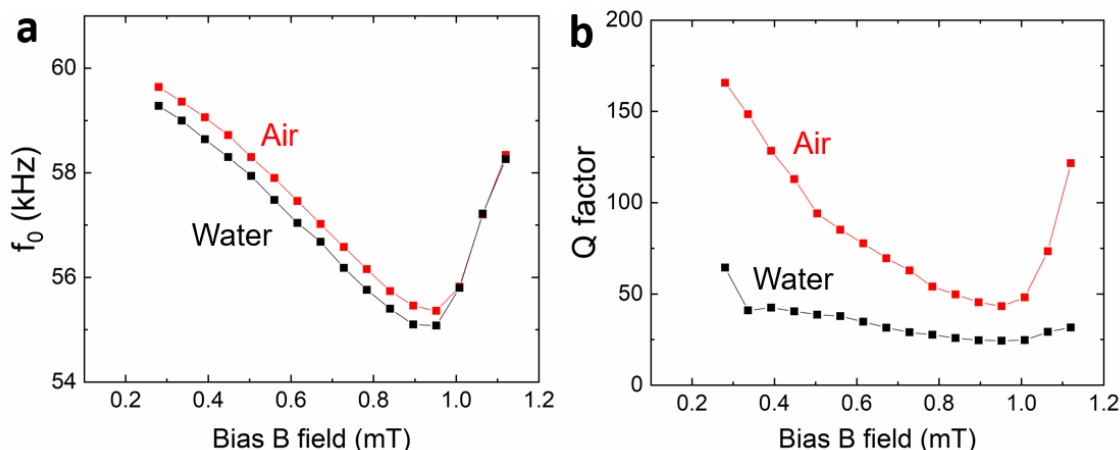


Figure S2. a) The resonance frequency of the magnetostrictive sensor at different dc bias fields at room temperature. b) Q -factor of the magnetostrictive sensor in air and water at different bias fields. Q -factor was calculated using the ratio of resonance frequency to the full-width half maximum of the resonance curve.

Thermo-magneto-mechanical model:

The following equations represent the 1D constitutive relations between the strain (ϵ), magnetization (M), and the applied magnetic field (H). We modify previously reported constitutive relations [1] to include the temperature dependence for Young's modulus at magnetic saturation (E_s).

$$\epsilon = \frac{\sigma}{E_s(1 + \gamma\Delta T)} + \alpha\Delta T - \frac{\lambda_s\beta\Delta TM^2}{M_s^2} + \begin{cases} \lambda_s \tanh\left(\frac{\sigma}{\sigma_s}\right) + \frac{(1 - \tanh\left(\frac{\sigma}{\sigma_s}\right))\lambda_s M^2}{M_s^2}, & \frac{\sigma}{\sigma_s} \geq 0 \\ \frac{\lambda_s}{2} \tanh\left(\frac{2\sigma}{\sigma_s}\right) + \frac{(2 - \tanh\left(\frac{2\sigma}{\sigma_s}\right))\lambda_s M^2}{2M_s^2}, & \frac{\sigma}{\sigma_s} < 0 \end{cases} \quad (S1)$$

$$M = M_s^T \left(\coth\left(\frac{3\chi H_{eff}}{M_s^T}\right) - \frac{M_s^T}{3\chi H_{eff}} \right) \quad (S2)$$

$$M_s^T = M_s \sqrt{\frac{\left(1 - \frac{\Delta T + T_r}{T_c}\right)}{\left(1 - \frac{T_r}{T_c}\right)}} \quad (S3)$$

$$H_{eff} = H - \frac{2\lambda_s\beta\Delta T\sigma M}{\mu_0 M_s^2} + \begin{cases} \frac{\left[2\sigma - 2\sigma_s \ln\left(\cosh\left(\frac{\sigma}{\sigma_s}\right)\right)\right]\lambda_s M}{\mu_0 M_s^2}, & \frac{\sigma}{\sigma_s} \geq 0 \\ \frac{\left[4\sigma - \sigma_s \ln\left(\cosh\left(\frac{2\sigma}{\sigma_s}\right)\right)\right]\lambda_s M}{2\mu_0 M_s^2}, & \frac{\sigma}{\sigma_s} < 0 \end{cases} \quad (S4)$$

Where,

ϵ is the strain in the magnetostrictive material,

M is the magnetization of the magnetostrictive material,

M_s is the saturation magnetization at room temperature,

M_s^T is the saturation magnetization at a temperature T ,

λ_s is the saturation magnetostrictive strain at room temperature,

H is the applied magnetic field,

H_{eff} is the effective applied magnetic field,

χ is the magnetic susceptibility of the magnetostrictive material,

σ is the compressive film stress,

σ_S is the stress at which magnetostrictive strain $\lambda = \lambda_S$ (ref),

ΔT is the change in temperature from a room temperature of 25°C,

T_r is the reference or room temperature,

T_C is the Curie temperature,

α is the thermal coefficient of expansion, which is given by $\alpha = \frac{1}{L} \frac{dL}{dT}$,

β is the temperature coefficient of the magnetostrictive strain (λ), which is given by $\beta = -\frac{1}{\lambda} \frac{d\lambda}{dT}$,

γ is the temperature coefficient of the Young's modulus at magnetic saturation (E_S),

μ_0 is the vacuum permeability.

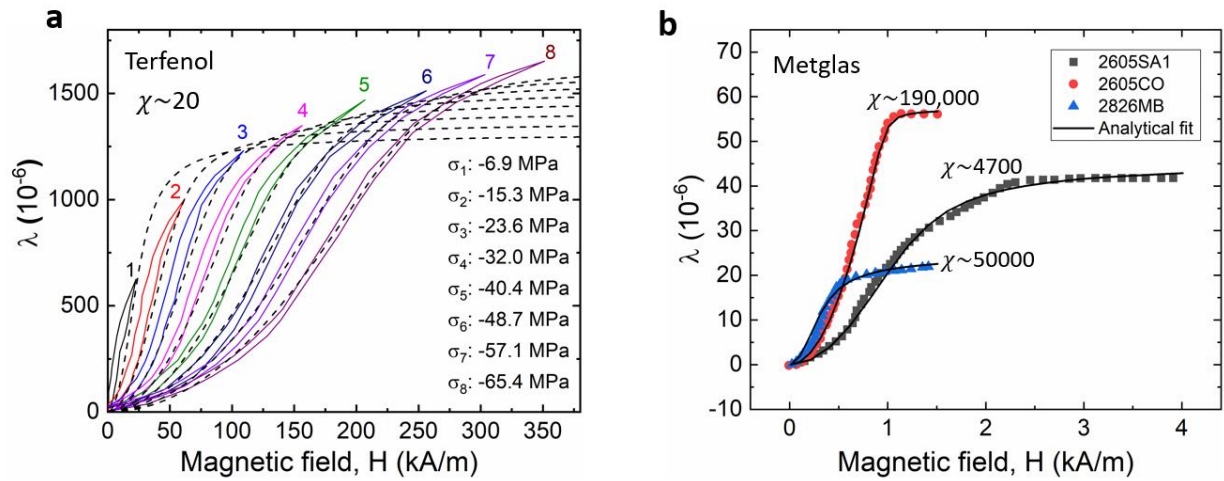


Figure S3. a) Magnetostrictive strain (λ) of Terfenol rods are shown for different bias fields and compressive stresses. The solid lines correspond to previously published experimental data, whereas the dashed lines represent our analytical fit. No fitting parameters were used. The material properties and experimental data we used can be found in Refs. [1]–[3]. b) Magnetostrictive strain (λ) of Metglas rods are shown for different bias fields. Dots represent experimental points from previous reports [4]–[6]. Solid lines represent our analytical fits. The extracted susceptibility (χ) values are shown in the graph. The corresponding fitted stress (σ) values were 18 MPa, 28 MPa, 25 MPa for 2826, 2605SA, 2605CO, respectively. Other material properties can be found in [5]–[13]. The magnetic susceptibility (χ) is dependent on the annealing conditions [14]–[16], and the obtained susceptibilities from the fit are within the expected order of magnitude based on previous reports [5]–[13].

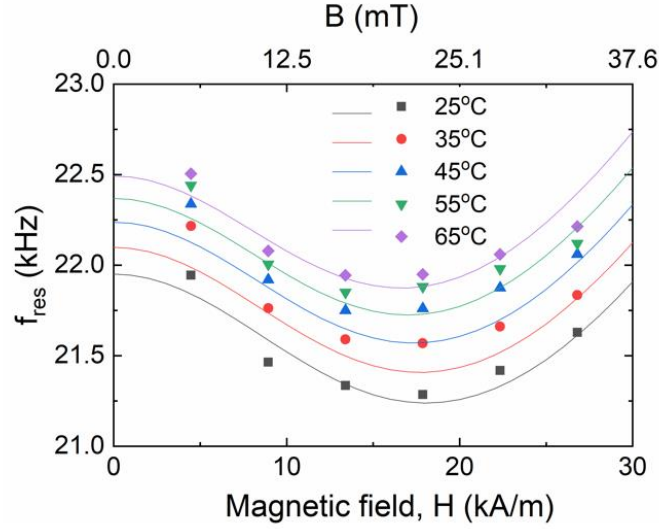


Figure S4. The resonance frequency of Terfenol rod at different temperatures and dc bias fields. The dots represent our experimental data points. The solid lines are representative of the fitting from both the analytical model and finite element simulations separately. The extracted fitting parameters were: $E_s=72$ MPa, $\gamma=4.2\times 10^{-3}$ K $^{-1}$, $\beta=10^{-3}$ K $^{-1}$, $\lambda_s=800$ ppm, $\sigma=1$ MPa, $\sigma_s=30$ MPa, $T_c=380^\circ\text{C}$, $M_s=1.2$ T, $\chi=25$, $\rho=9200$ kg/m 3 . The material parameters used for fitting are in close agreement within an order of magnitude of previously reported values [1]–[3]. Any deviation could be attributed to the use of a thin layer (5 μm) of Parylene that we deposited on the Terfenol laminates to prevent corrosion.

Fitting parameters:

For Figure 6 of the manuscript:

Fit parameters:

$$E_s=84 \text{ MPa,}$$

$$\gamma=-3.6\times 10^{-4} \text{ K}^{-1}, \beta=1.4\times 10^{-3} \text{ K}^{-1},$$

$$\lambda_s=18 \text{ ppm,}$$

$$\sigma=17 \text{ MPa, } \sigma_s=17 \text{ MPa,}$$

$$T_c=395^\circ\text{C,}$$

$$M_s=1 \text{ T,}$$

$$\chi=50000,$$

$$\rho=7900 \text{ kg/m}^3.$$

The fit material parameters ($E_s, \gamma, \beta, \lambda_s, T_c, M_s, \chi, \rho$) are in good agreement within an order of magnitude of previously reported values [5]–[13]. The stress values (σ, σ_s) were the only other fit parameters, and they strongly depend on the sensor strip fabrication process. They are typically measured through a stress (σ) vs. magnetostrictive strain curve (λ) [17] and are not known a priori for our magnetostrictive samples.

For Figure 7 of the manuscript:

Electrical circuit fit parameters: $R_e=1 \text{ } \Omega$, $L^S=0.27 \text{ mH}$ (these are in good agreement with the measured values for the ac coil used in the experiment)

Kinematic circuit fit parameters: $R=5400 \text{ N}\cdot\text{m}^{-1}\text{s}$, $M=0.3 \text{ N}\cdot\text{m}^{-1}\text{s}^2$, $C^H=28 \text{ N}^{-1}\text{m}$, $\theta=0.09 \text{ N}\cdot\text{A}^{-1}$; for finite element simulations: $\Theta=26$, $\xi=0.018$ (damping factor).

Supplementary References:

- [1] X. J. Zheng and L. Sun, “A nonlinear constitutive model of magneto-thermo-mechanical coupling for giant magnetostrictive materials,” *Journal of Applied Physics*, vol. 100, no. 6, p. 063906, Sep. 2006, doi: 10.1063/1.2338834.
- [2] “Terfenol-D - ETREMA Products, Inc.,” *TdVib, LLC*. <http://tdvib.com/terfenol-d/> (accessed Aug. 21, 2020).
- [3] M. B. Moffett, A. E. Clark, M. Wun-Fogle, J. Linberg, J. P. Teter, and E. A. McLaughlin, “Characterization of Terfenol-D for magnetostrictive transducers,” *The Journal of the Acoustical Society of America*, vol. 89, no. 3, pp. 1448–1455, Mar. 1991, doi: 10.1121/1.400678.
- [4] A. E. Clark and M. Wun-Fogle, “A new method of magnetostrictivity and magnetostriction measurement,” *IEEE Transactions on Magnetics*, vol. 25, no. 5, pp. 3611–3613, Sep. 1989, doi: 10.1109/20.42378.
- [5] J. Zhai, S. Dong, Z. Xing, J. Li, and D. Viehland, “Giant magnetoelectric effect in Metglas/polyvinylidene-fluoride laminates,” *Appl. Phys. Lett.*, vol. 89, no. 8, p. 083507, Aug. 2006, doi: 10.1063/1.2337996.
- [6] M. H. Kim, K. S. Lee, and S. H. Lim, “Magnetostriction measurements of metallic glass ribbon by fiber-optic Mach–Zehnder interferometry,” *Journal of Magnetism and Magnetic Materials*, vol. 191, no. 1, pp. 107–112, Jan. 1999, doi: 10.1016/S0304-8853(98)00310-2.
- [7] A. P. Thomas and M. R. J. Gibbs, “Anisotropy and magnetostriction in metallic glasses,” *Journal of Magnetism and Magnetic Materials*, vol. 103, no. 1, pp. 97–110, Jan. 1992, doi: 10.1016/0304-8853(92)90242-G.
- [8] “Materials from Metglas®, Inc.,” *Metglas, Inc.* <https://metglas.com/magnetic-materials/> (accessed Aug. 21, 2020).
- [9] R. Schulz, N. Alexandrov, J. Tétreault, R. Simoneau, and R. Roberge, “Development and application of amorphous core-distribution transformers in Québec,” *JMEP*, vol. 4, no. 4, pp. 430–434, Aug. 1995, doi: 10.1007/BF02649303.
- [10] G. H. Hayes, W. A. Hines, D. P. Yang, and J. I. Budnick, “Low field magnetic anisotropy in Metglas 2605 CO ribbons,” *Journal of Applied Physics*, vol. 57, no. 8, pp. 3511–3513, Apr. 1985, doi: 10.1063/1.335044.
- [11] B. Kundys, Y. Bukhantsev, H. Szymczak, M. R. J. Gibbs, and R. Zuberek, “Temperature dependence of saturation magnetostriction measured for Fe₈₁Si_{3.5}B_{13.5}C₂ amorphous films by a bending method based on the Villari effect,” *J. Phys. D: Appl. Phys.*, vol. 35, no. 11, pp. 1095–1098, May 2002, doi: 10.1088/0022-3727/35/11/301.
- [12] Z. Turgut, H. Kosai, T. Bixel, J. Scofield, S. L. Semiatin, and J. Horwath, “Hysteresis loss analysis of soft magnetic materials under direct current bias conditions,” *Journal of Applied Physics*, vol. 117, no. 17, p. 17A508, May 2015, doi: 10.1063/1.4919228.
- [13] S. R. Green and Y. B. Gianchandani, “Wireless Magnetoelastic Monitoring of Biliary Stents,” *Journal of Microelectromechanical Systems*, vol. 18, no. 1, pp. 64–78, Feb. 2009, doi: 10.1109/JMEMS.2008.2008568.
- [14] M. Brouha and J. van der Borst, “The effect of annealing conditions on the magneto-mechanical properties of Fe-B-Si amorphous ribbons,” *Journal of Applied Physics*, vol. 50, no. B11, pp. 7594–7596, Nov. 1979, doi: 10.1063/1.326769.
- [15] A. Houzali, F. Alves, J. C. Perron, and R. Barrué, “A new technique for dynamic annealing of amorphous alloys using Joule effect with controlled mechanical tensile stress,” *Review of Scientific Instruments*, vol. 66, no. 9, pp. 4671–4675, Sep. 1995, doi: 10.1063/1.1145305.
- [16] M. Mouhamad, C. Elleau, F. Mazaleyra, C. Guillaume, and B. Jarry, “Physicochemical and Accelerated Aging Tests of Metglas 2605SA1 and Metglas 2605HB1 Amorphous Ribbons for

- Power Applications,” *IEEE Transactions on Magnetics*, vol. 47, no. 10, pp. 3192–3195, Oct. 2011, doi: 10.1109/TMAG.2011.2158295.
- [17] X. J. Zheng and X. E. Liu, “A nonlinear constitutive model for Terfenol-D rods,” *Journal of Applied Physics*, vol. 97, no. 5, p. 053901, Feb. 2005, doi: 10.1063/1.1850618.